

PROCEEDINGS OF SPIE

Current Developments in Lens Design and Optical Engineering IX

Pantazis Z. Mouroulis
Warren J. Smith
R. Barry Johnson
Editors

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Dedication

This conference is dedicated to the memory of Warren J. Smith. Warren was among the founding chairs of the Current Developments series that began in 1986 and a co-chair of each conference up to this one. This, however, was only one of his many accomplishments, which are well known to most lens designers and optical engineers and hardly need to be repeated here.

It is hard to find anyone else who personified lens design and optical engineering as fully as Warren. His long career of 60+ years has exerted a major influence in the field through his books, publications, teaching, and mentoring of younger engineers. And for all his achievements and fame, he exhibited kindness, lack of pretense, and a remarkable sense of humor. As we celebrate Warren's contributions to our field, we cannot help but notice that one of our guiding lights has sadly dimmed.



Warren J. Smith (1922-2008)
Optical engineer, educator, friend, mentor, gentleman.

